

Datasheet: MakroPor M1-200

Etching

Size: 6 inch

Pitch: 1.5 μm trigonal

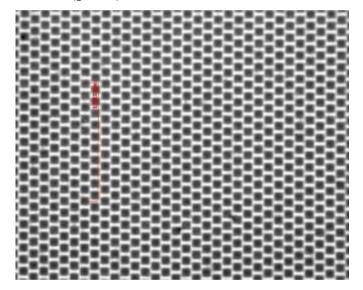
 $\begin{array}{ll} \text{Length:} & 200 \ \mu\text{m} \\ \\ \text{Diameter:} & 1.0 \ \mu\text{m} \\ \end{array}$

Postprocessing

Membrane lift off Laser dicing

Images

Front side (generic)



Remarks

- Lifted backsides are sensitive to mechanical handling. Abrasion of silicon nanotips is visible as brown "scratches" on the surface but have minor effect on the underlying pores. We suggest using vacuum tweezers on the front side. Depending on the thickness, <u>flat tips with small diameters are preferred instead of suction cup tips</u>, to minimize mechanical Stress.
- Please be aware: Thin membranes may flip due to electrostatic forces while opening or closing transport boxes!
- According to our "MakroPor factsheet", this structure has a funnel shaped pore entrance followed by a slight bottleneck (depth in the range of the pore diameter) on the front surface.